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#GAU 1165

Express Mail Label No.:  
EJ037500455US

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Gene LEE et al.

Appln. No.: 10/039,333

Group Art Unit: 1765

Filed: November 9, 2001

Examiner: B. Tran

Title: Method for Etching Tungsten  
Using NF<sub>3</sub> and Cl<sub>2</sub>

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TC 1700

## TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Enclosed please find the following:

1. Request for Reconsideration;
2. Rule 131 Declaration of Gene Lee;
3. Exhibit: Invention Alert (six pages); and
4. Petition for Extension of Time.

The Director of the U.S. Patent & Trademark Office is hereby authorized to charge the extension of time fee of \$970.00 to Deposit Account No. 18-1579. The Director is also authorized to charge any fee deficiency, or credit any overpayment, to Deposit Account No. 18-1579. A duplicate copy of this letter is enclosed.

Respectfully submitted,

ROBERTS ABOKHAIR &amp; MARDULA, LLC

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